

SEP 20 2007

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/671,922  
Confirmation No. .... 8459  
Filing Date ..... September 24, 2003  
Inventor ..... Garo J. Derderian et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2812  
Examiner ..... Lynne Ann Gurley  
Attorney's Docket No. .... MI22-2296  
Customer No. .... 021567  
Title: Atomic Layer Deposition Methods, and Methods of Forming Materials  
Over Semiconductor Substrates

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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Dated: 9/20/2007By: 

Natalie King, Legal Assistant  
Telephone No. (509) 624-4276  
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NUMBER OF PAGES IN FACSIMILE: 3

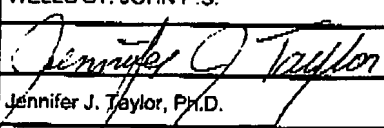
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<b>TRANSMITTAL FORM</b>	Application Number	10/671,922
	Filing Date	September 24, 2003
	First Named Inventor	Garo J. Dardarian et al.
	Art Unit	2812
	Examiner Name	Ahmadi Mohsen
	Attorney Docket Number	MI22-2296
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Total Number of Pages in This Submission		

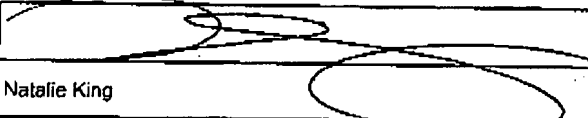
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Remarks _____ Customer No. 021567		

**SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT**

Firm Name	WELLS ST. JOHN P.S.		
Signature			
Printed name	Jennifer J. Taylor, Ph.D.		
Date	September 20, 2007	Reg. No.	48,711

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Signature			
Typed or printed name	Natalie King	Date	September 20, 2007

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Appl. No. 10/671,922

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Semiconductor Substrates

STATEMENT OF THE SUBSTANCE OF AUGUST 9, 2007 INTERVIEW

On 09 August 2007 an interview was conducted by telephone concerning the above referenced application. Participants of the interview were Examiner Mohsen Ahmadi and Jennifer J. Taylor. The interview did not include any exhibits or demonstrations. In response to the Office communication dated 20 August 2007, I, Jennifer J. Taylor, do hereby set forth the substance of such interview.

Claims 35, 37, 38, 39, 40, 41, and 43 were discussed. An agreement was reached to incorporate subject matter from claim 40 and intervening claim 38 into claim 35 and that claim 35 would be allowable over the art of record. Authorization to amend claims 35, 37, 39, 41, and 43 by examiner's amendment was given with cancellation of claim 40 and intervening claim 38.

Respectfully submitted,

Dated: 20 September 2007By: Jennifer J. TaylorJennifer J. Taylor, Ph.D.  
Reg. No. 48,711